

Docket No. AMENDMENT TRANSMITTAL LETTER M4065.0319/P319-A Filing Date Application No. Examiner **Art Unit** 09/912,558 July 26, 2001 Erik J. Kielin 2813 Applicant(s): Ronald A. Weimer, et al. FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN Invention: INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS TO THE COMMISSIONER FOR PATENTS Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below. **CLAIMS AS AMENDED** Claims **Highest** Number Remaining Number **After** Previously **Extra Claims Present** Rate Amendment Paid 0.00 **Total Claims** 29 30 X Independent 0.00 6 6 X Claims Multiple Dependent Claims (check if applicable) Other fee (please specify): 0.00 TOTAL ADDITIONAL FEE FOR THIS AMENDMENT: **Small Entity** x Large Entity x No additional fee is required for this amendment. Please charge Deposit Account No. in the amount of \$ A duplicate copy of this sheet is enclosed. A check in the amount of \$ to cover the filing fee is enclosed. Payment by credit card. Form PTO-2038 is attached. X The Commissioner is hereby authorized to charge and credit Deposit Account No. 04-1073 as described below. A duplicate copy of this sheet is enclosed. Credit any overpayment. Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17. August 8, 2002 Dated: Stephen A. Soffen Attorney Reg. No.: 31,063 TECHNOLOGY CENTER 2800 **DICKSTEIN SHAPIRO MORIN & OSHINSKY LLP** 2101 L Street NW RECEIVED Washington, DC 20037-1526 (202) 828-2232 2 2002